

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

EUN-SEOK CHOI, ET AL.

Application No.:

Filed:

For: **Method of Manufacturing
Ferroelectric Memory Device**

Art Group:

Examiner:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

Applicant respectfully requests a convention priority for the above-captioned application, namely:

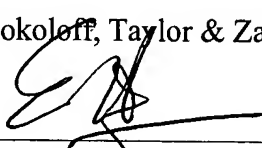
COUNTRY	APPLICATION NUMBER	DATE OF FILING
Korea	10-2002-0086308	30 December 2002

☒ A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Dated: 7/14/03


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